



INTERNATIONAL
GEMOLOGICAL
INSTITUTE

ELECTRONIC COPY

LABORATORY GROWN DIAMOND REPORT

September 4, 2025

IGI Report Number

LG729508311

Description

LABORATORY GROWN DIAMOND

Shape and Cutting Style

ROUND BRILLIANT

Measurements

7.41 - 7.47 X 4.56 MM

GRADING RESULTS

Carat Weight

1.54 CARAT

Color Grade

D

Clarity Grade

VVS 1

Cut Grade

IDEAL

ADDITIONAL GRADING INFORMATION

Polish

EXCELLENT

Symmetry

EXCELLENT

Fluorescence

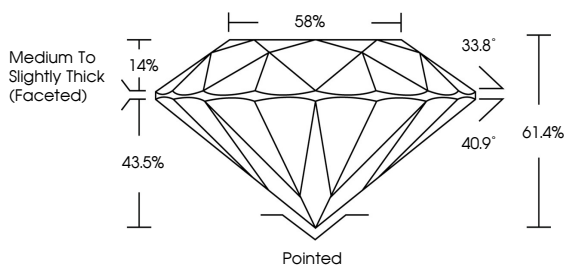
NONE

Inscription(s)

 LG729508311

Comments: This Laboratory Grown Diamond was created by Chemical Vapor Deposition (CVD) growth process. Type IIa

PROPORTIONS



Medium To Slightly Thick (Faceted)

58%

33.8°

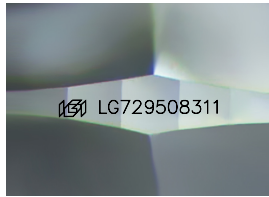
40.9°

61.4%

43.5%

14%

Pointed



Sample Image Used

COLOR

D

E

F

G

H

I

J

Faint

Very Light

Light

CLARITY

FL

IF

VVS¹⁻²

VS¹⁻²

SI¹⁻²

I¹⁻³

Flawless

Internally Flawless

Very Very Slightly Included

Very Slightly Included

Slightly Included

Included



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ADDITIONAL GRADING INFORMATION

Polish

EXCELLENT

Symmetry

EXCELLENT

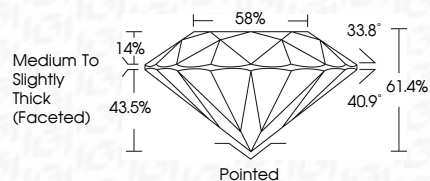
Fluorescence

NONE

Inscription(s)

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Medium To Slightly Thick (Faceted)

58%

33.8°

40.9°

61.4%

43.5%

14%

Pointed



September 4, 2025

IGI Report No LG729508311

ROUND BRILLIANT

7.41 - 7.47 X 4.56 MM

1.54 CARAT

D

VVS 1

IDEAL

88%

Medium To Slightly Thick (Faceted)

Pointed

EXCELLENT

EXCELLENT

NONE

 LG729508311

Cutler

Polish

Symmetry

Fluorescence

Inscription(s)

None

EXCELLENT

EXCELLENT

NONE

 LG729508311

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